

03500.014179

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
 YOICHI ANDO ET AL.  
 Application No.: 09/722,454  
 Filed: November 28, 2000  
 For: METHOD FOR MANUFACTURING ELECTRON BEAM DEVICE,  
 METHOD FOR MANUFACTURING IMAGE FORMING APPARATUS,  
 ELECTRON BEAM DEVICE AND IMAGE FORMING APPARATUS  
 MANUFACTURED THOSE MANUFACTURING METHODS,  
 METHOD AND APPARATUS FOR MANUFACTURING ELECTRON SOURCE AND APPARATUS FOR MANUFACTURING IMAGE FORMING APPARATUS

Examiner: M. Santiago

Group Art Unit: 2879

July 7, 2003

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

*11/ elect  
 G. Staley  
 7-9-03*

*FAX RECEIVED  
 JUL 07 2003  
 TECHNOLOGY CENTER 2800  
 FAX RECEIVED  
 JUL 07 2003  
 TECHNOLOGY CENTER 2800*

RESPONSE TO RESTRICTION AND ELECTION REQUIREMENTS

Sir:

This is in response to the Office Action dated June 5, 2003, imposing restriction and election requirements in the above-identified application.

I hereby certify that this correspondence is being facsimile-transmitted to the United States Patent and Trademark Office, Fax No. (703) 872-9318, on

\_\_\_\_\_  
 July 7, 2003  
 (Date of Transmission)

\_\_\_\_\_  
 Jason M. Okun  
 (Name of Attorney for Applicant(s))

*Jason M. Okun*  
 Signature \_\_\_\_\_  
 July 7, 2003  
 Date of Signature